

BEST AVAILABLE COPY

FIGURE 1

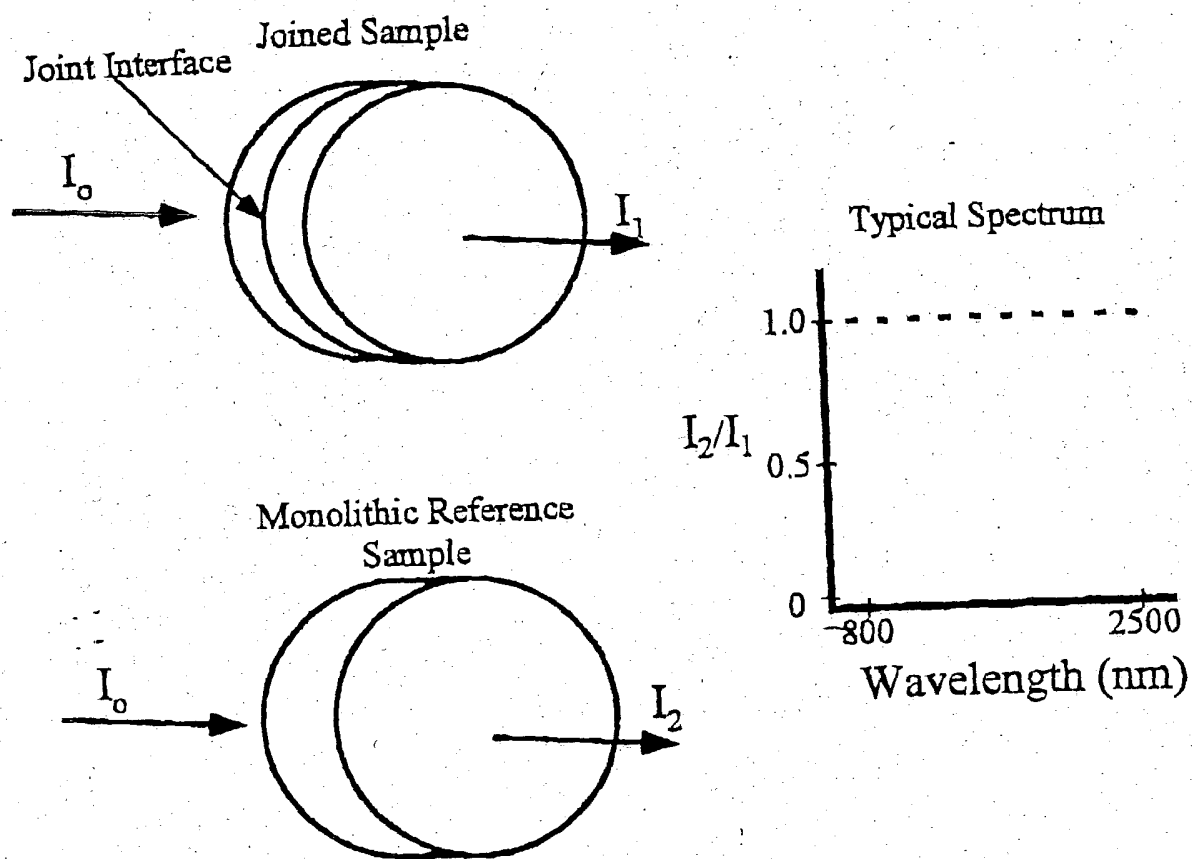


FIGURE 2

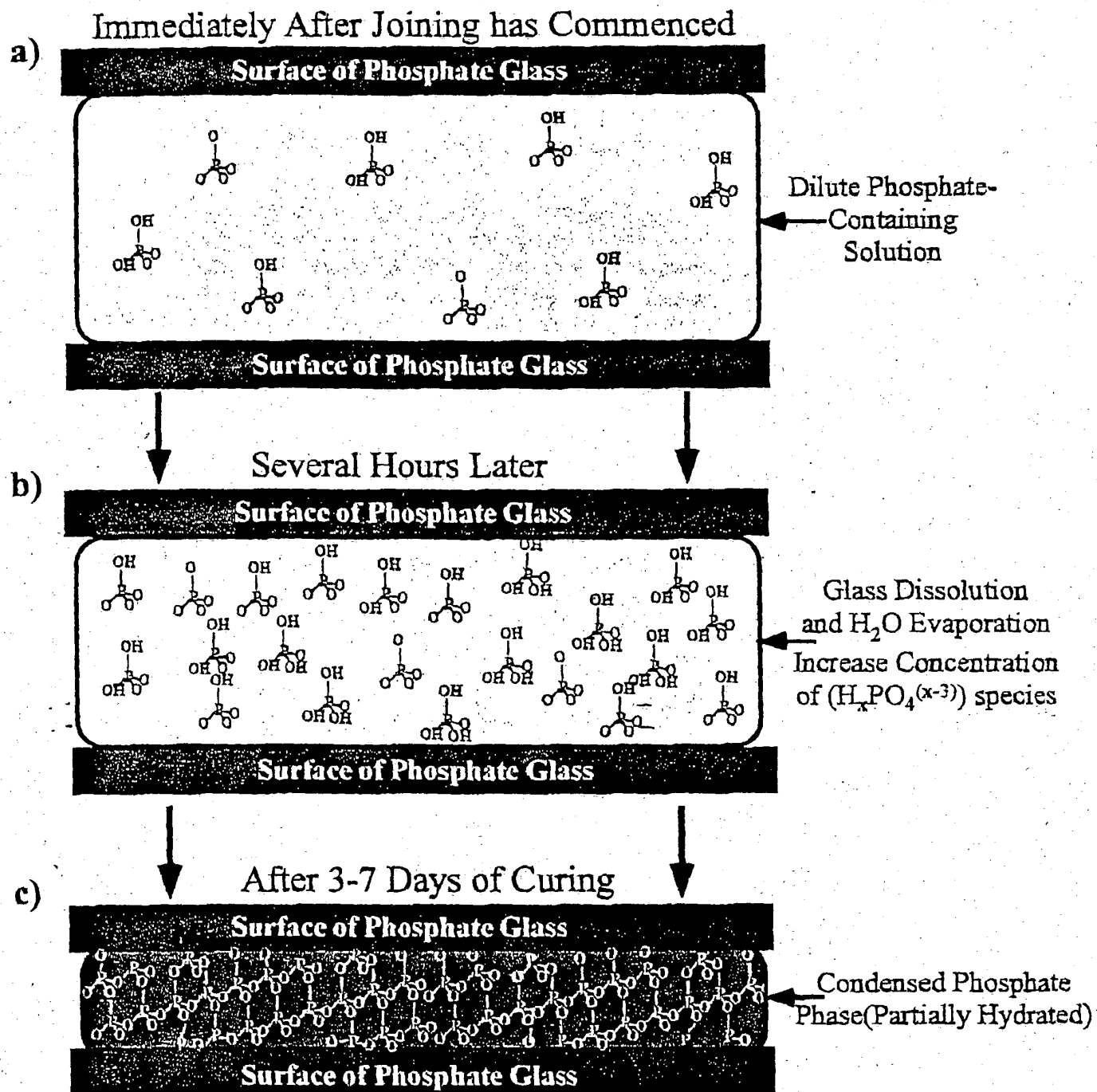


FIGURE 3

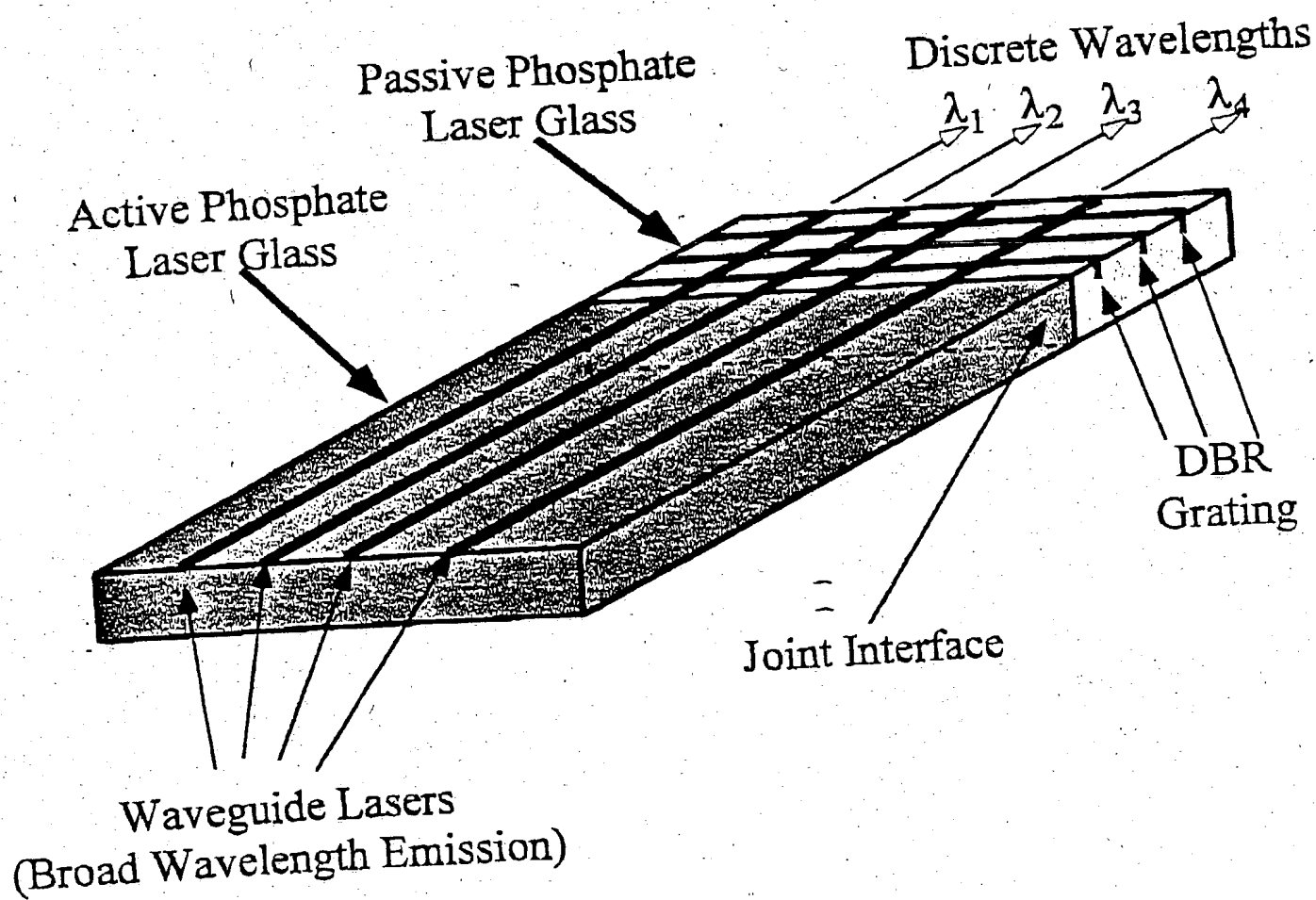


FIGURE 4

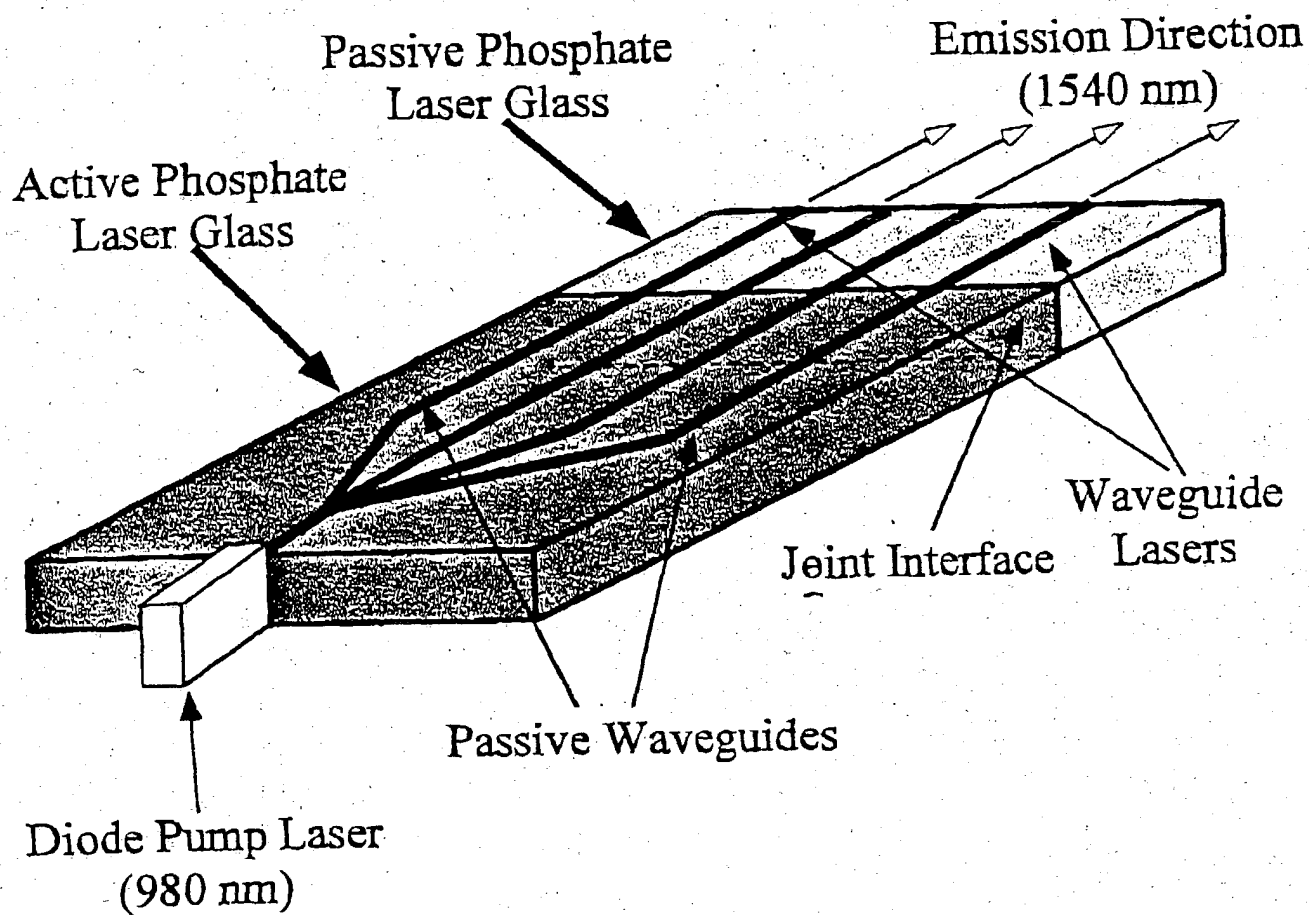


FIGURE 5

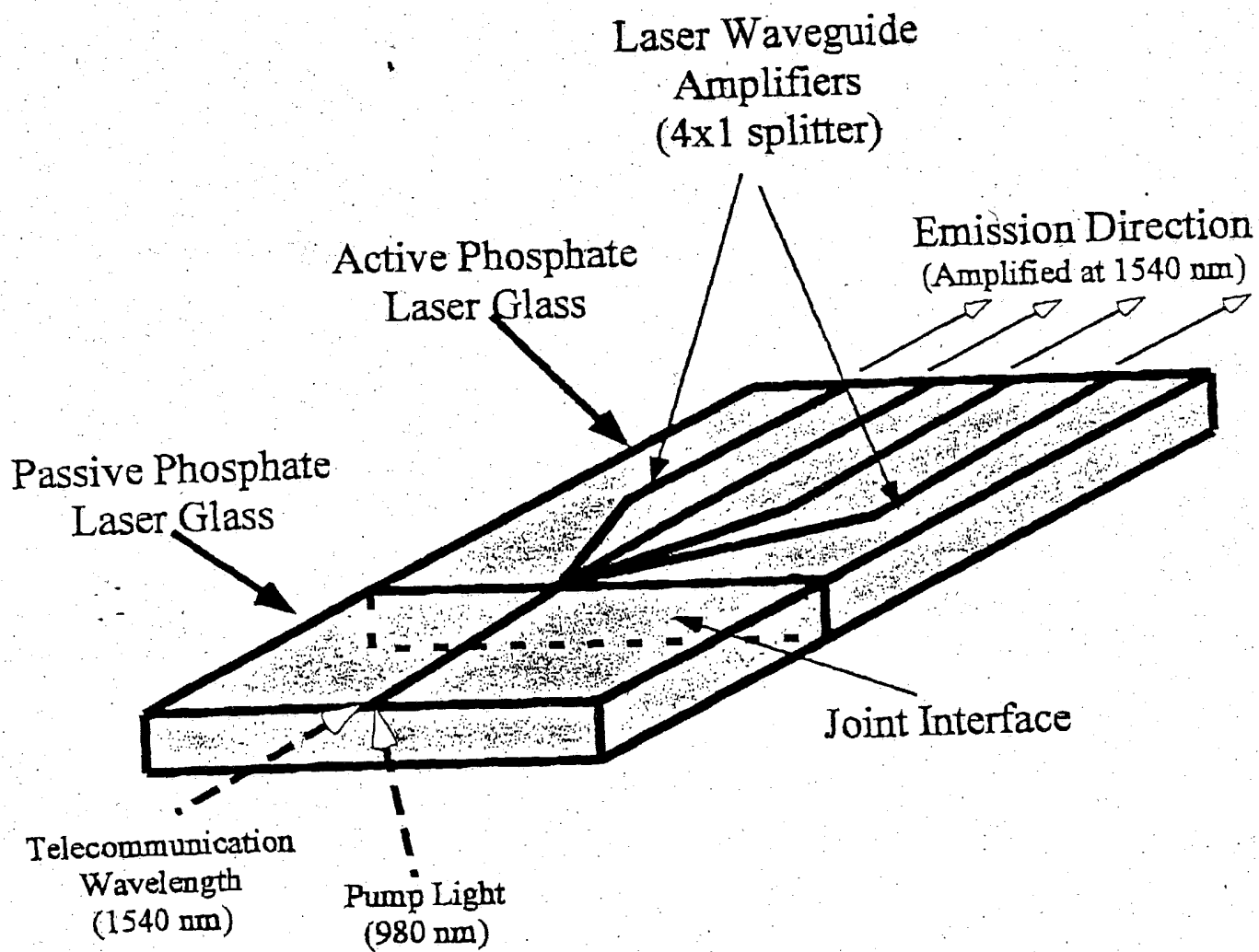
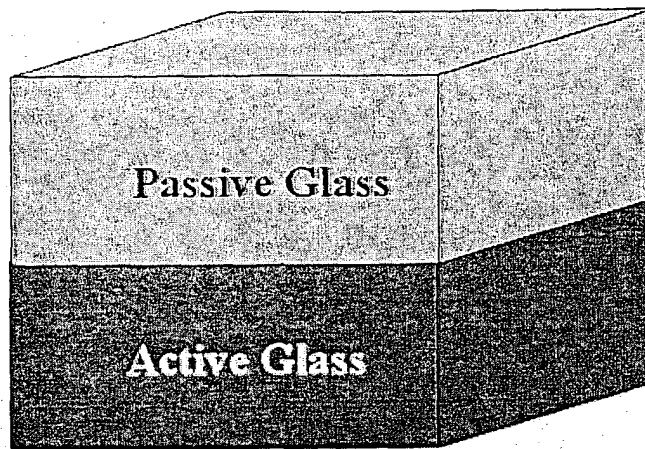


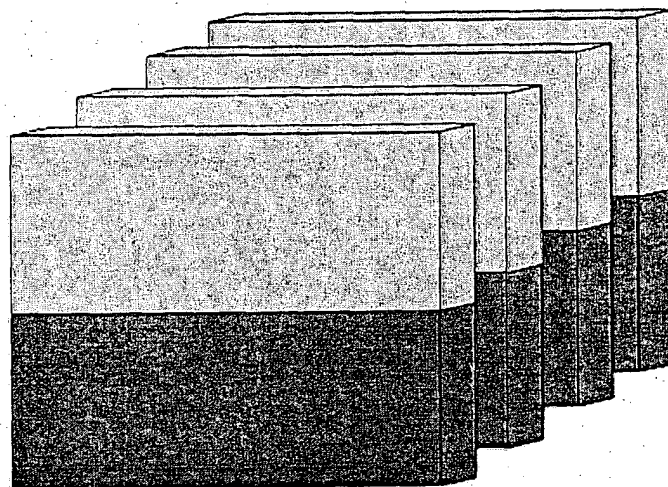
FIGURE 6

**Preform:**  
Joined By a  
Low Temperature Process



↓ Cutting, Grinding  
and Polishing ↓

**Individual  
Hybrid Glass Substrates**



↓ Photolithography  
and Ion Exchange ↓

**Individual Device:**  
No Active Alignment Necessary

